Product name:	Product code:
Optical Encoder Position Measurement Training System	CMI-NP-1777



Description

Optical Encoder Position Measurement Training System is a system studying quadrature optical encoders for linear and rotary position measurement.

Technical specification

Light source	LED and diode laser < 1 mW

Standard Accessories

- Lens set
- Fibre cable
- Experiment manual

The Optical Encoder Position Measurement Training System is a system studying quadrature optical encoders for linear and rotary position measurement. It is designed for training in opto-electronic components, light-based measurement and optical devices combined with mechatronic control.

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Features

- Optical bench with movable carriers
- Combines optics with sensors and actuators
- Suitable for optics, photonics and mechatronics courses
- Safe low-power laser and LED sources

Technical Specifications

Linear scale	200 mm, 5 um
Rotary	2500 PPR
Display	Counter with LCD
Supply	230 V AC, 50 Hz, single phase
Optical bench	1000 mm rail